

<b>Notice of References Cited</b>	Application/Control No. 10/065,296	Applicant(s)/Patent Under Reexamination LIN ET AL.	
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**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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	B	US-5,767,538 A	06-1998	Mullins et al.	257/115
	C	US-			
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	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

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**NON-PATENT DOCUMENTS**

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	U	Van Zant, Microchip Fabrication, 4th ed. McGraw-Hill: New York, 2000, pp. 72-74.
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\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
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